

## IN THE U.S. PATENT AND TRADEMARK OFFICE

I N F O R M A T I O N   S H E E T

Applicant:        NAKABAYASHI, Tetsuya  
                  UJIMASA, Hitoshi  
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Application No.:

Filed:             March 21, 2001

For:               SUSCEPTOR AND SURFACE PROCESSING METHOD

Priority Claimed Under 35 U.S.C. 119 and/or 120:

COUNTRY	DATE	NUMBER
JAPAN	03/21/00	2000-078321
JAPAN	01/10/01	2001-002081

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The above information is submitted to advise the USPTO of all relevant facts in connection with the present application. A timely executed Declaration in accordance with 37 CFR 1.64 will follow.

Respectfully submitted,

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By

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